FEE TRANSMITTAL

Electronic Version v08

Stylesheet Version v08.0

Title of Invention

Method of Forming Thin Silicon Oxide Films on Silicon Carbide Substrates

Application Number:

Date:

First Named Applicant: Andrew M. Hoff
Attorney Docket Number: 1372.80.PRC

TOTAL FEE AUTHORIZED \$ 385

Patent fees are subject to annual revisions on or about October 1st of each year.

Filing as small entity

BASIC FILING FEE

Fee Description	Fee Code	Amount \$	Fee Paid \$			
Utility Filing Fee	2001	385	385			
Subtotal For Basic Filing Fees: \$ 385						

EXTRA CLAIM FEES

Fee Description	Extra Claim	Fee Code	Amount \$	Fee Paid \$		
Total Claims: 10	0	2202	9	0		
Independent Claims : 3	0	2201	43	0		
Subtotal For Extra Claims Fees: \$ 0						

AUTHORIZED BILLING INFORMATION

The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:

Credit account number: 3008

Expiration Date (YYYYMMDD): 2004-05-31

Authorized name: Anton J. Hopen

Billing address: 33760